## **EUROPEAN PATENT OFFICE**

## Patent Abstracts of Japan

**PUBLICATION NUMBER** 

10134740

PUBLICATION DATE

22-05-98

APPLICATION DATE

30-10-96

APPLICATION NUMBER

08303540

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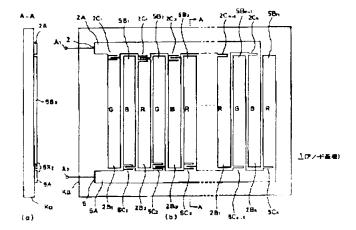
INT.CL.

: H01J 31/12 H01J 31/15

TITLE

: FIELD EMISSION TYPE DISPLAY

**ELEMENT** 



ABSTRACT :

PROBLEM TO BE SOLVED: To suppress micro discharging, enhance a voltage withstanding property, improve light emitting efficiency of a phosphor and reduce power consumption with high luminance by forming resistors having different resistances at leading-out portions of stripe electrodes.

SOLUTION: An anode voltage VA is supplied to anode electrodes 2, 5 of conducting portions 2A, 5A via terminals A<sub>1</sub>, A<sub>2</sub>, respectively. Stripe electrodes 2B<sub>1</sub>-2B<sub>0</sub>, 5B<sub>1</sub>-5B<sub>0</sub> are formed at the anode electrodes 2, 5, respectively. The stripe electrodes are patterned by photolithography in such a manner as to have a gap of 10µm or more therebetween so as to prevent color mixture at the time of light emission of a phosphor. Furthermore, resistors 2C<sub>1</sub>-2C<sub>n</sub>, 5C<sub>1</sub>-5C<sub>n</sub> are formed at leading-out portions of the stripe electrodes, wherein different resistances are provided by varying the number of slits and the size of slit interval-s. Consequently, when micro discharging is generated between an anode substrate and a cathode substrate, an effective voltage can be decreased.

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